



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Chien-Chao Huang, et al.	§	Docket No.:	2003-0964 / 24061.150
Serial No.:	10/824,854	§	Examiner:	Julio J. Maldonado
Filing Date:	April 15, 2004	§	Art Unit:	2823
For:	Method of Manufacturing a	§	Conf. No.:	6844
	Microelectronic Device with	§		
	Electrode Perturbing Sill	§		

**RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop: Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed May 17, 2005, applicants hereby elect Group II, Claims 17-38, which is drawn to a semiconductor device.

Applicant's election is made with traverse on the grounds that the embodiments delineated by the examiner are not patentably distinct and therefore constitute a single invention concept.

An early action on the merits is respectfully requested.

Respectfully submitted,

David M. O'Dell  
Reg. No. 42,044

Date: 6-1-05

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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop: Amendment, Commissioner For Patents, PO Box 1450, Alexandria, VA 22313-1450 on the date below.

Bonnie Boyle  
Name  
6-1-05  
Date